



Search Notes 	Application/Control No. 10693619	Applicant(s)/Patent Under Reexamination RONNEKLEIV, ERLAND
	Examiner Detschel, Marissa J	Art Unit 2877

Notes	Date	Examiner
Confirmed IDS documents	09/28/2006	MJD
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<p style="text-align: center;">Searched</p> 	<p>Application/Control No.</p> <p>10693619</p>	<p>Applicant(s)/Patent Under Reexamination</p> <p>RONNEKLEIV, ERLAND</p>
	<p>Examiner</p> <p>Detschel, Marissa J</p>	<p>Art Unit</p> <p>2877</p>

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356	477, 478, 479	09/28/2006	MJD
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